



Attorney Docket No. 09459.0002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: |) |
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| Toshihisa NOZAWA et al. |)) Group Art Unit: 3652)) Examiner: Gina M. Lupino)) Confirmation No.: 7239)) |
| Application No.: 10,786,068 | |
| Filed: February 26, 2004 | |
| For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD | |

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants petition for a one month extension of time to file a reply to the Office Action of July 5, 2006. A fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter the attached reply and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

/David W. Hill/ Dated: November 3, 2006

David W. Hill Reg. No. 28,220

DWH/CKA/sas

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